



## Lesson 7



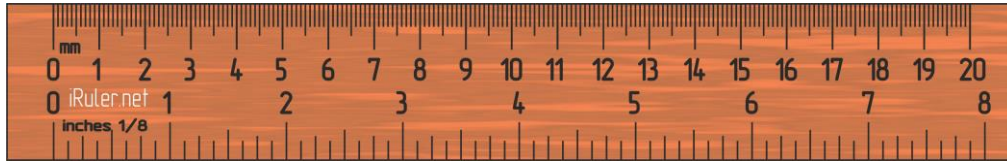
# Thermomechanical Measurements for Energy Systems (MENR)

# Measurements for Mechanical Systems and Production (MMER)

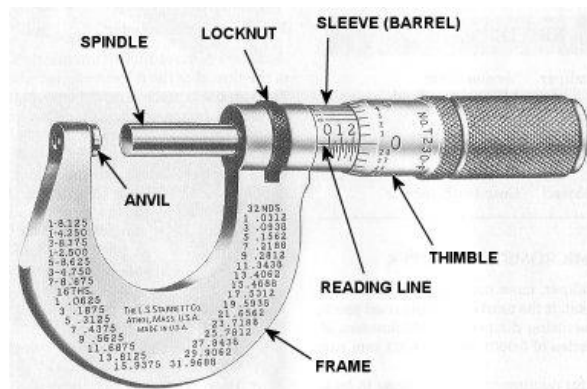
# Length and displacement measurement

Many instruments are available to measure length and displacement in modern technology ...

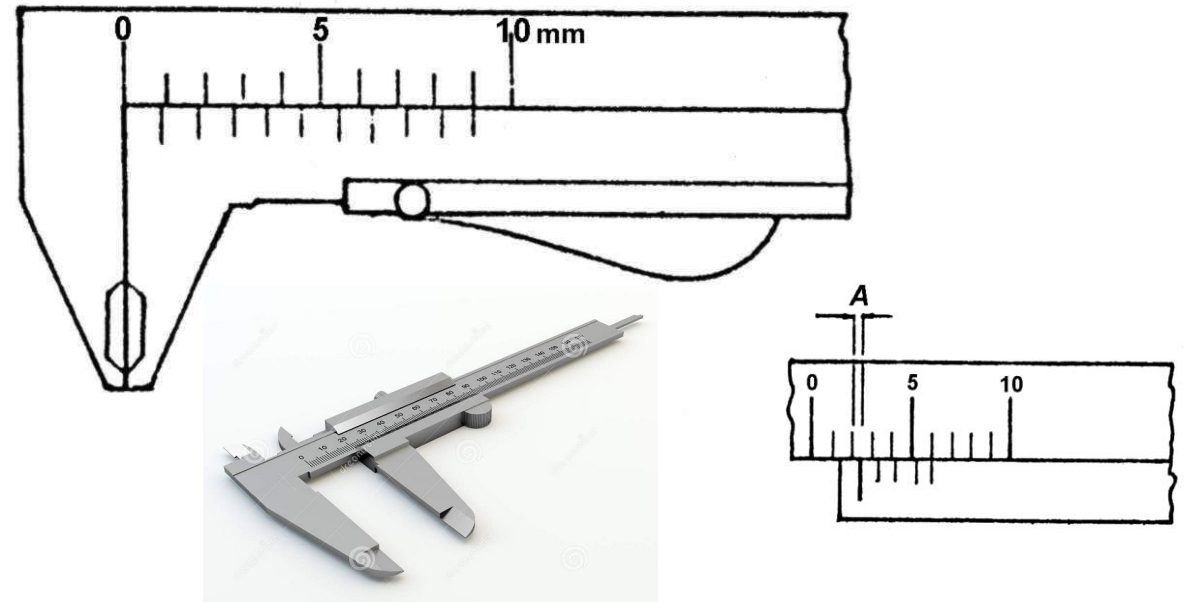
The most ancient is the **graduated ruler**:



**Rulers** have an approximation of 1 mm, while **Vernier Calipers** have an approximation of 0,1 mm (over an average range of 200 mm) ! If you need more resolution, you have to use the **Micrometer**, which has an approximation of 0,01 mm (over a range of 25 mm) !

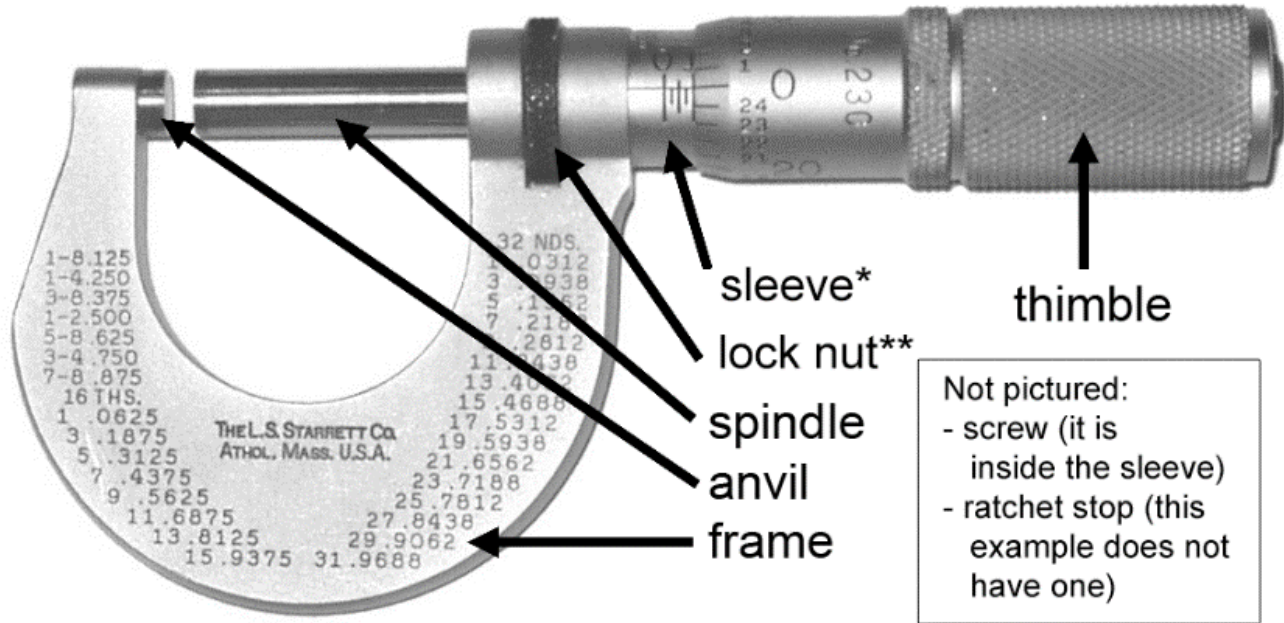


For small length the **Vernier Caliper** is used in the Lab:



It subdivides 9 mm in 10 parts, each of which is therefore 0,9 mm long. When measuring, you count the first *mobile notch* coinciding with any *fixed notch* and you add that “tenth of millimeter” (A) to your reading !

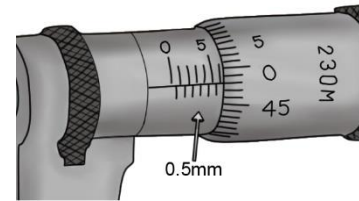
The **Micrometer (Palmer)** is based on a “micrometric screw” with a *pitch* of 0.5 mm (*sleeve*)



\*Sleeve is the most prevalent name. May also be called the *barrel* or *stock*.

\*\*Aka *lock-ring*. Some mics have a *lock lever* instead.

There are 50 notches on the rotating screw (*thimble*), therefore for every notch the screw advances:

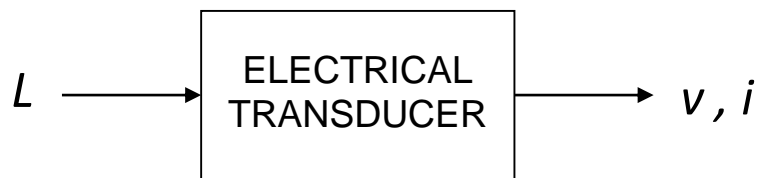


$$\frac{1}{2} \cdot \frac{1}{50} = \frac{1}{100} \text{ mm,}$$

which is also the approximation of the instrument !

Of course the range is limited by the instrument screw opening ...

However in the industry, almost all the **displacement transducers** are electrical:



They are generally based on the Ohm's law:  $V = Z \cdot I$

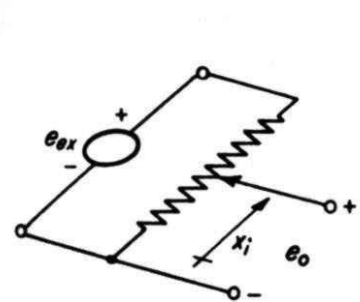
With the impedance: 
$$Z = \sqrt{R^2 + \left(\omega L - \frac{1}{\omega C}\right)^2}$$

We have already seen the **potentiometers**, where  $Z = R = \rho \cdot \frac{l}{S}$  and the graduation curve is:  $e_o = \frac{e_{ex}}{l} \cdot x$

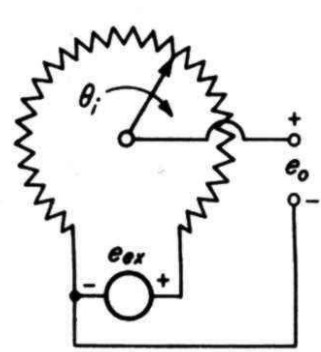
with a *constant sensitivity* expressed in [V/m]  $S = \frac{de_o}{dx} = \frac{e_{ex}}{l}$

For **rotational potentiometers** we have:

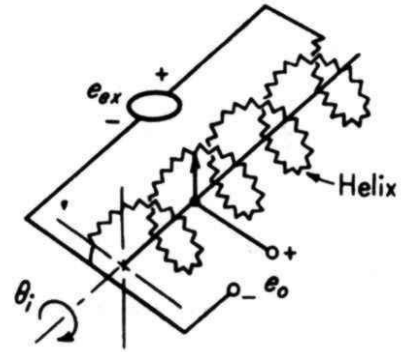
$$e_o = \frac{e_{ex}}{2\pi} \cdot \theta$$



Translational

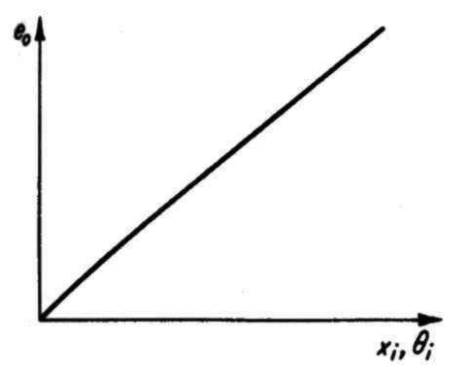


Single-turn

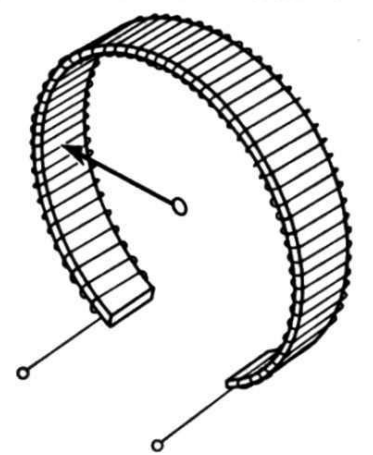
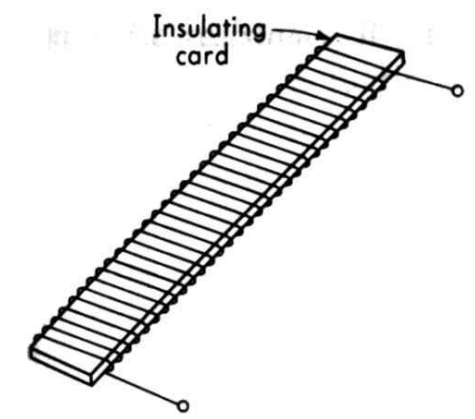
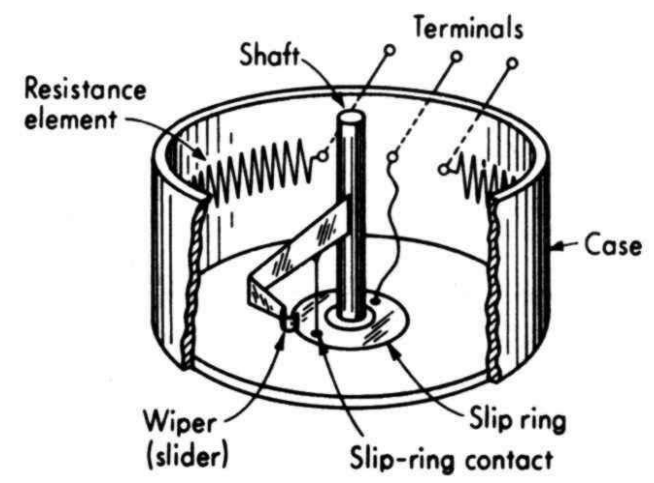


Multiturn

Rotational



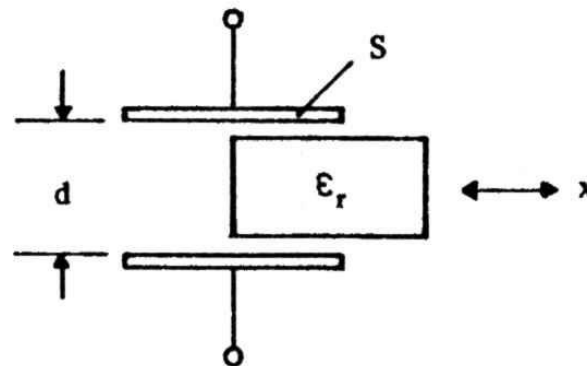
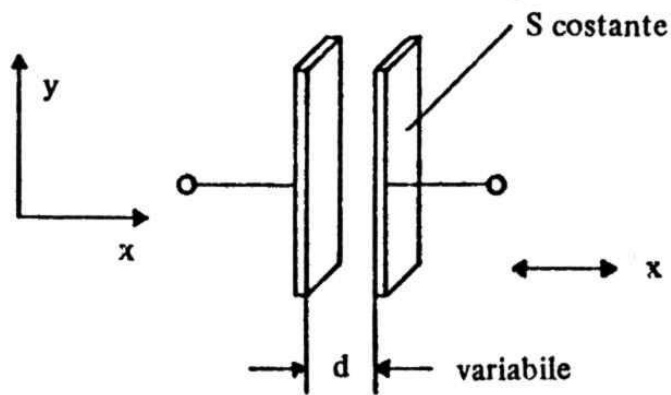
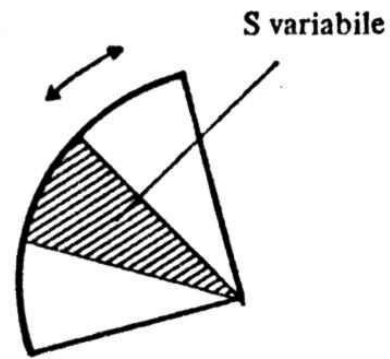
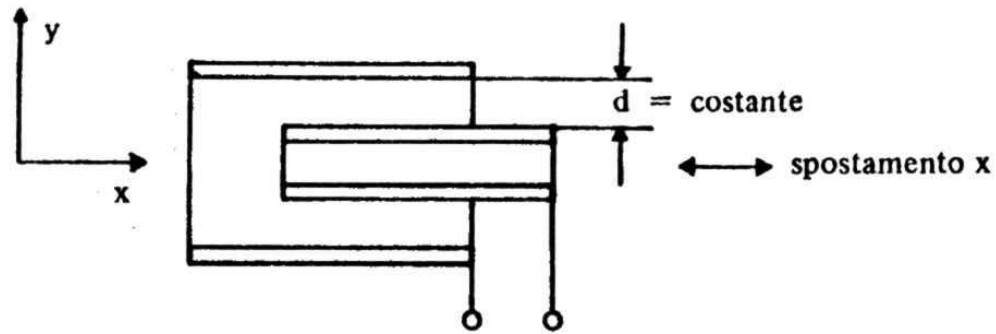
Potentiometer displacement transducer.



Formed into circle

Construction of wirewound resistance elements.

**Capacitive transducers** are all based on the fundamental physical relationship:  $C = \epsilon_0 \epsilon_r \frac{S}{d}$



$S = \text{costante}$        $\epsilon_r = \text{variabile}$   
 $d = \text{costante}$

We can vary the “distance  $d$ ” but then we did not get a *constant sensitivity*:

$$\frac{dC}{d(d)} = -\epsilon_0 \epsilon_r \frac{S}{d^2}$$

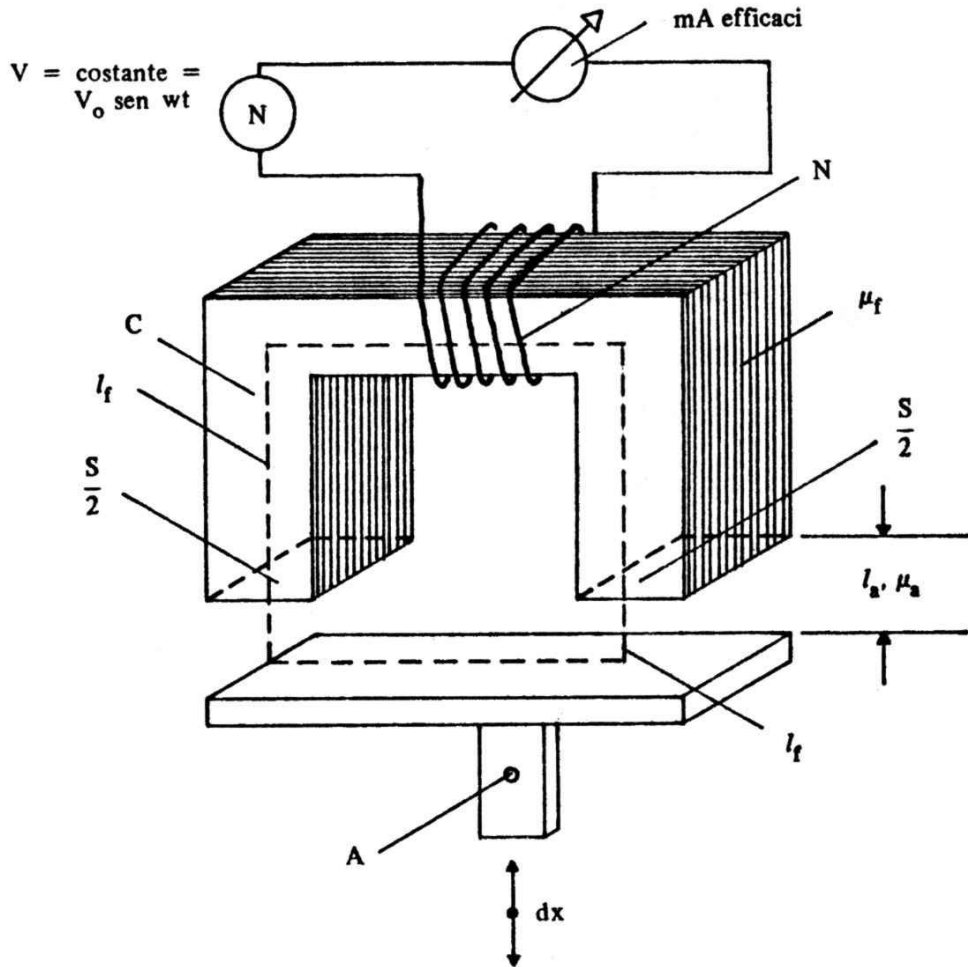
or we can vary the “plates surface  $S$ ” (good for rotating capacitor transducers) and we get a *constant sensitivity*:

$$\frac{dC}{dS} = \epsilon_0 \epsilon_r \frac{1}{d}$$

or we can even vary the “dielectric constant  $\epsilon_r$ ” and we get a constant sensitivity as well:

$$\frac{dC}{d\epsilon_r} = \epsilon_0 \frac{S}{d}$$

**Inductive transducers** are a bit more complex, for example in the **variable reluctance transducer** the inductance



$L = \mu_0 \mu_r \frac{N^2 S}{l}$  is changing because of a variation of

the magnetic circuit reluctance  $L = \frac{N^2}{\mathfrak{R}}$  where

$\mathfrak{R} = \frac{l}{\mu_0 \mu_r S}$  and it is:  $\mathfrak{R} = \mathfrak{R}_f + \mathfrak{R}_a$

Because  $\mu_f \geq 10000$  while  $\mu_a \cong 1$  even if  $l_f > l_a$

it basically results:  $L \cong \frac{N^2}{\mathfrak{R}_a}$

If we supply the coil with a "c.a. voltage":  $V = V_0 \sin \omega t$

we can apply  $V = Z \times I$  where  $\bar{Z} = R + j\omega L \cong j\omega L$

and the graduation curve is:

$$I_{eff} = \frac{2V_{eff}}{\omega N^2 \mu_0 \mu_a S} \cdot x$$

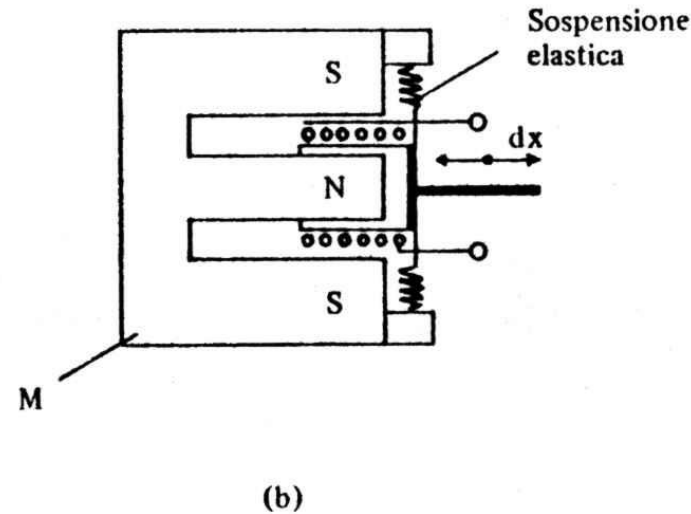
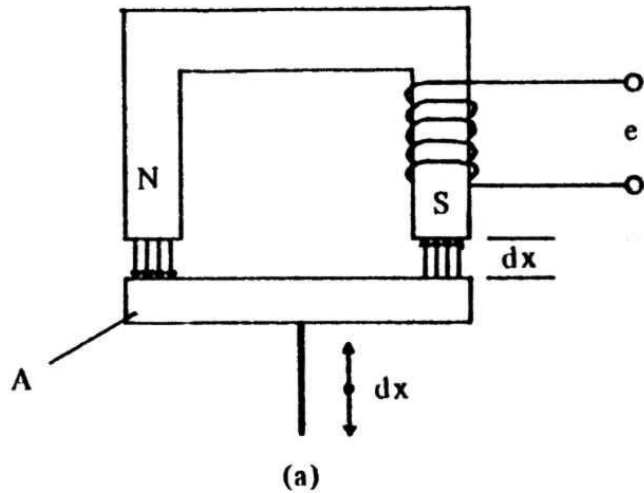
$$V = Z \cdot I \cong j\omega L \cdot I = j\omega \frac{N^2}{\mathfrak{R}_a} \cdot I = j\omega N^2 \mu_0 \mu_a \frac{S}{l_a} \cdot I$$

with a constant sensitivity:

$$S = \frac{\Delta I}{\Delta x} = \frac{2V_{eff}}{\omega N^2 \mu_0 \mu_a S}$$

There are also *simpler inductive transducers* which do not need a voltage supply, because they are based on *permanent magnets* and on the Faraday's law :

$$e_u = -N \frac{d\Phi}{dt} = -N \frac{d\Phi}{dx} \frac{dx}{dt} = -N \frac{d\Phi}{dx} \dot{x}$$



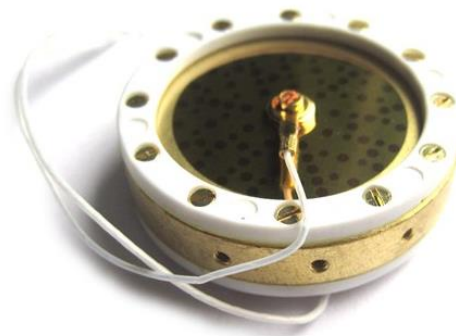
However, the output signal is proportional to the *velocity of the displacement*  $\dot{x}$  and needs to be integrated ...

The graduation curve is:

$$e_u = -Blv = -Bl\dot{x}$$









These are all contactless sensors !

Type (b) transducers are *reversible* and can become (with an appropriate design) **loudspeakers** !



A typical application of this kind of transducers is the **microphone pick-up** ...

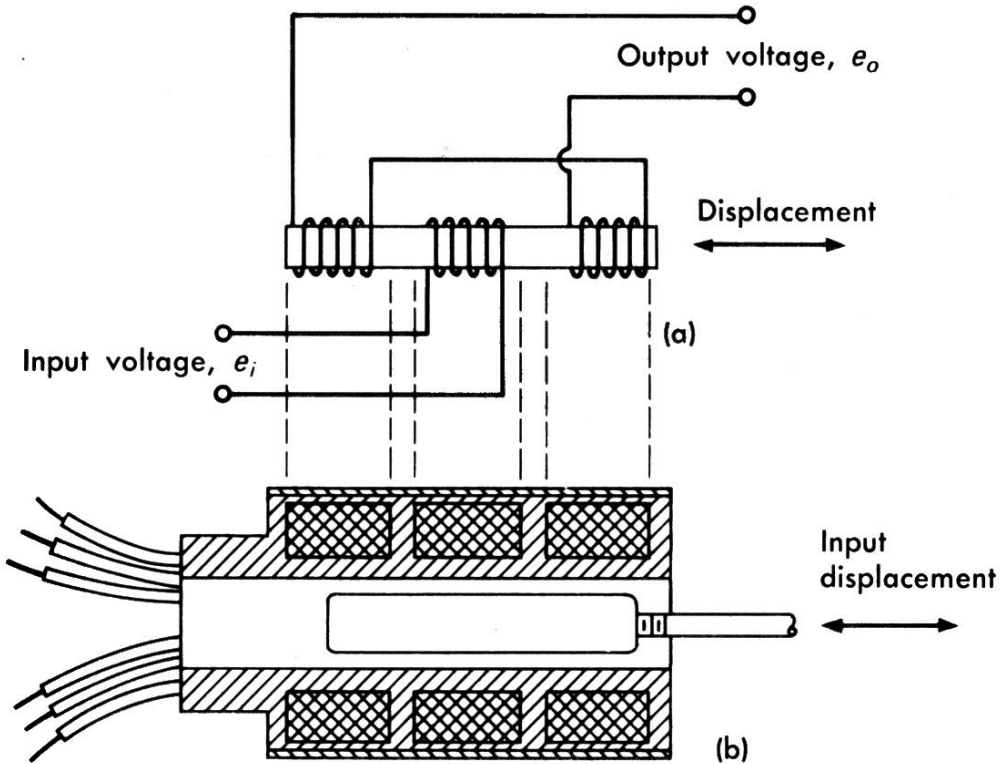
# Proximity sensor comparison

| <b>Technology</b>  | <b>Sensing range</b> | <b>Applications</b>  | <b>Target materials</b>   |
|--|----------------------|--|---|
| <b>Inductive</b><br>      | <4-40 mm             | Any close-range detection of ferrous material  | Iron<br>Steel<br>Aluminum<br>Copper<br>etc.                |
| <b>Capacitive</b><br>     | <3-60 mm             | Close-range detection of non-ferrous material  | Liquids<br>Wood<br>Granulates<br>Plastic<br>Glass<br>etc.  |
| <b>Photoelectric</b><br> | <1mm- 60 mm          | Long-range, small or large target detection  | Silicon<br>Plastic<br>Paper<br>Metal<br>etc.              |
| <b>Ultrasonic</b><br>   | <30 mm- 3 mm         | Long-range detection of targets with difficult surface properties. Color/reflectivity insensitive. | Cellophane<br>Foam<br>Glass<br>Liquid<br>Powder<br>etc.  |

courtesy of  
 “machinedesign.com”



The most important inductive transducer is the *Linear Variable Displacement Transducer (LVDT)*



One primary and two secondary coils are wrapped as in figure (a). A high permeability ( $\mu_r > 10000$ ) inner nucleus (b) picks up the displacement and engages the magnetic field produced by the primary coil ...

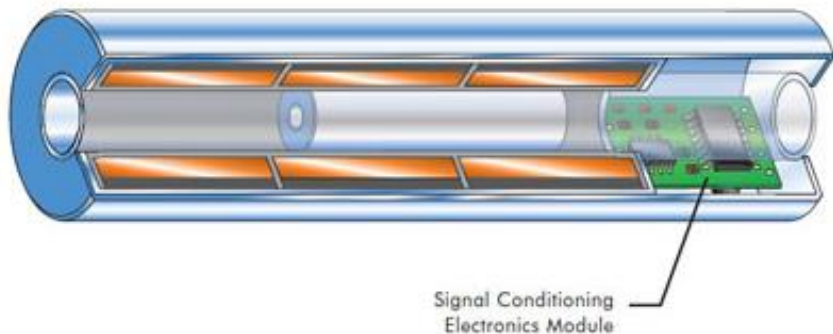
Input voltage  $E_i$  at the primary coil is, of course, a.c. Because the secondary coils are *winded series-opposing* the resulting output voltage  $E_o$  will be differential:

$$E_o = E_1 - E_2 = (M_{1p} - M_{2p}) \cdot \frac{di_p}{dt}$$

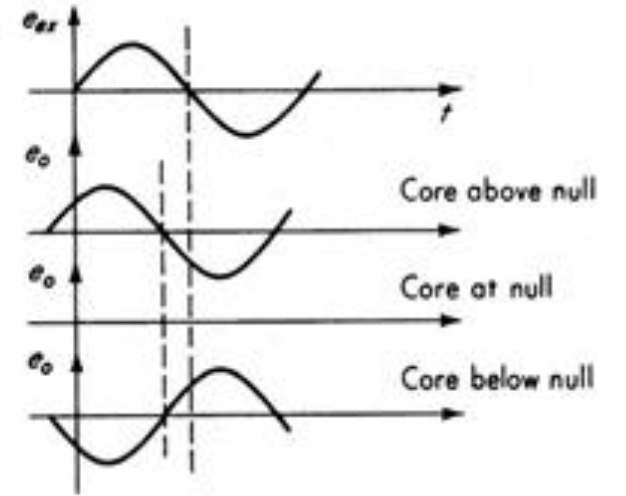
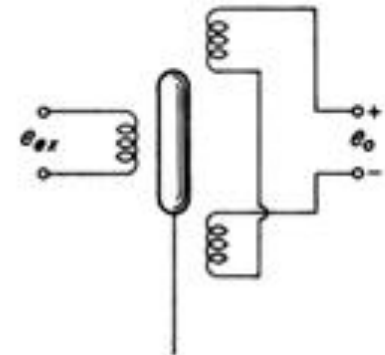
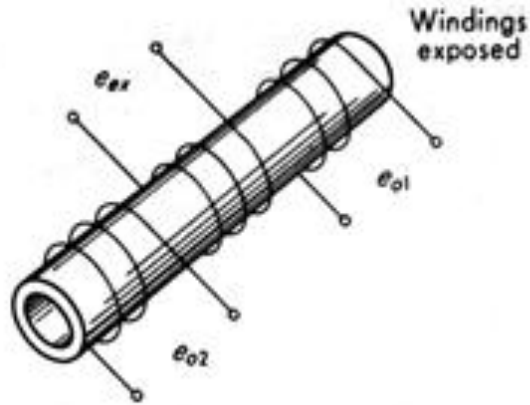
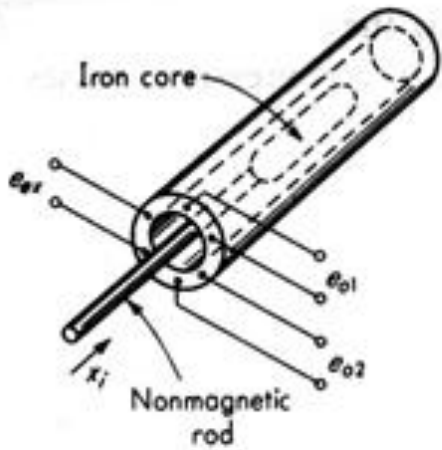
with the mutual inductance coefficients  $M_{ip} = \sqrt{L_i L_p}$

and  $L_i = \mu_o \mu_r \frac{N^2 S}{l}$  with  $i = 1, 2$

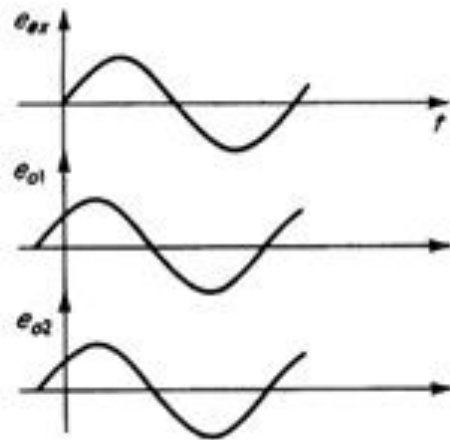
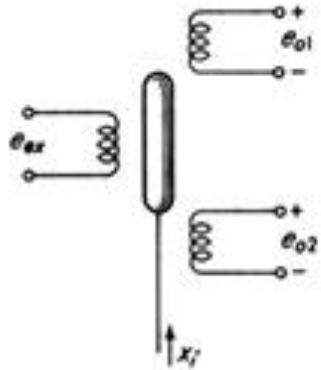
Note that the relationship above is valid for “every time instant” and is also preliminary form of the LVDT graduation curve !



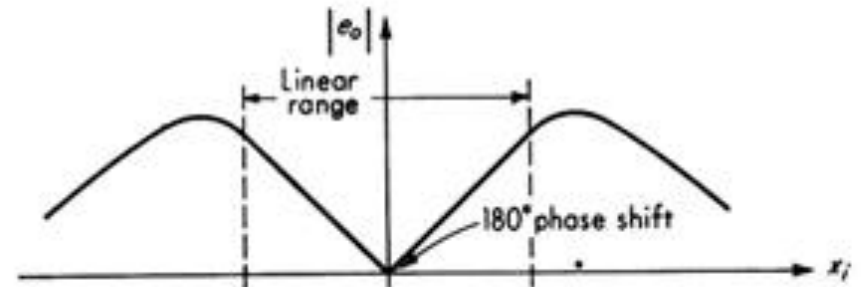
The right figure explains what is happening when the ferromagnetic nucleus moves from the *central null position*, copying the external displacement. It can be easily seen that the LVDT is an electric “zero method” transducer !



Series-opposing secondaries

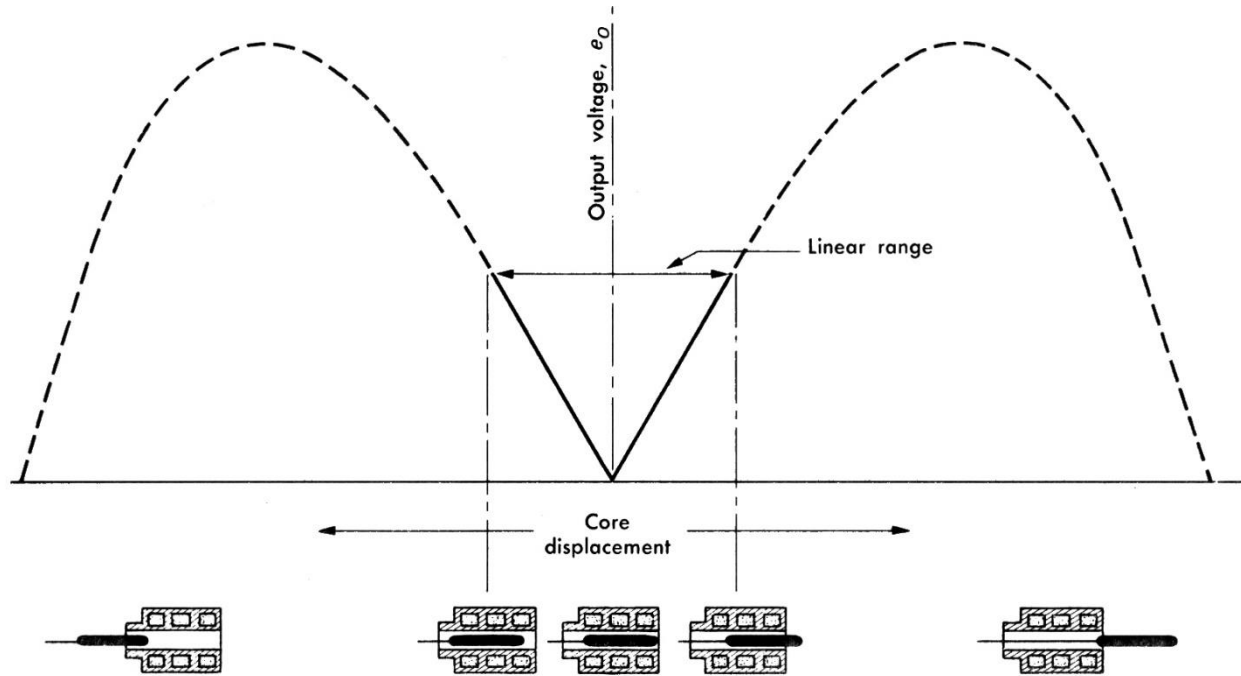


Core in null position

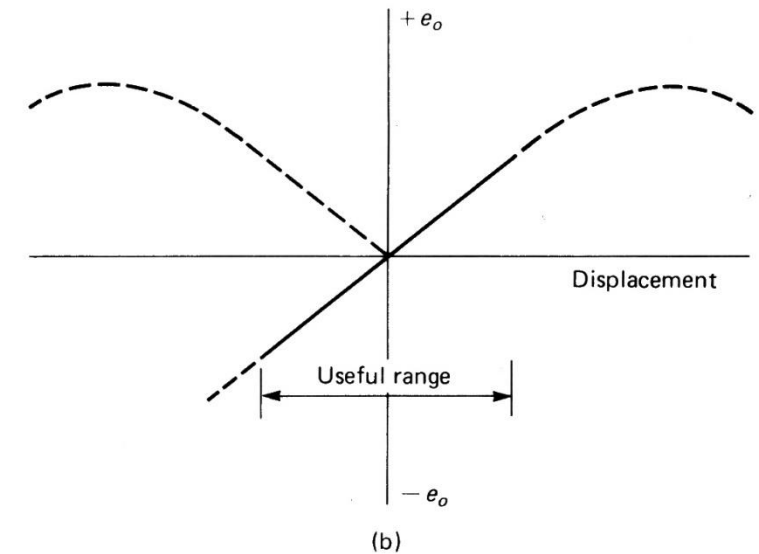
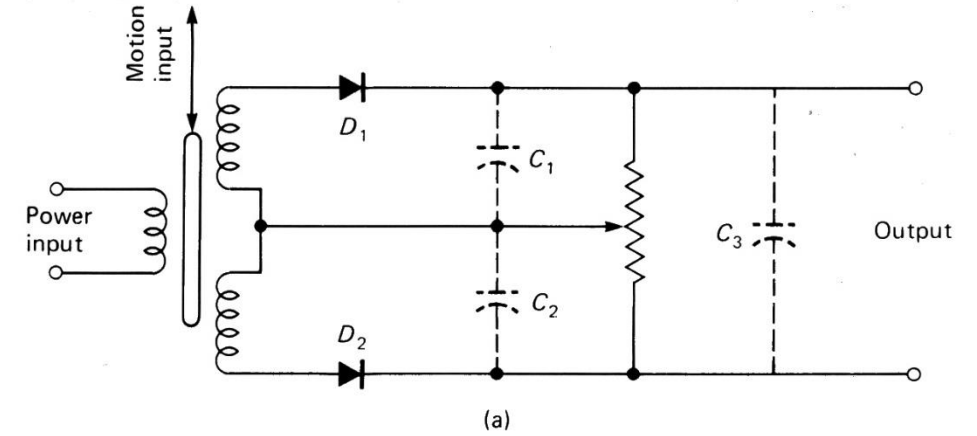


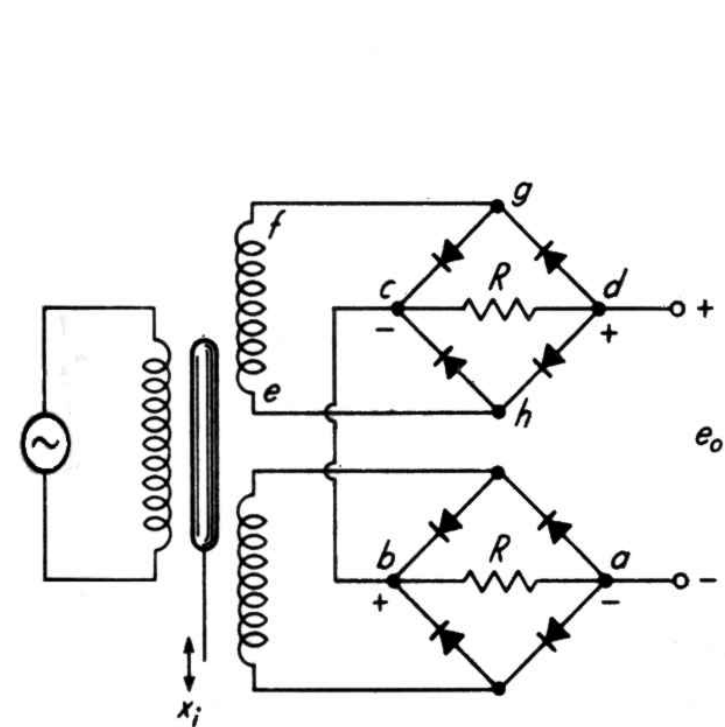
Differential transformer.

LVDT are not linear transducers but they can be considered linear in a limited range, near the central null position !



To read the output voltage, LVDT need a signal manipulation circuit that provides for the *rectification of the signal  $E_o$*  and a *phase discriminator* to understand if the displacement is happening towards the left or the right side !

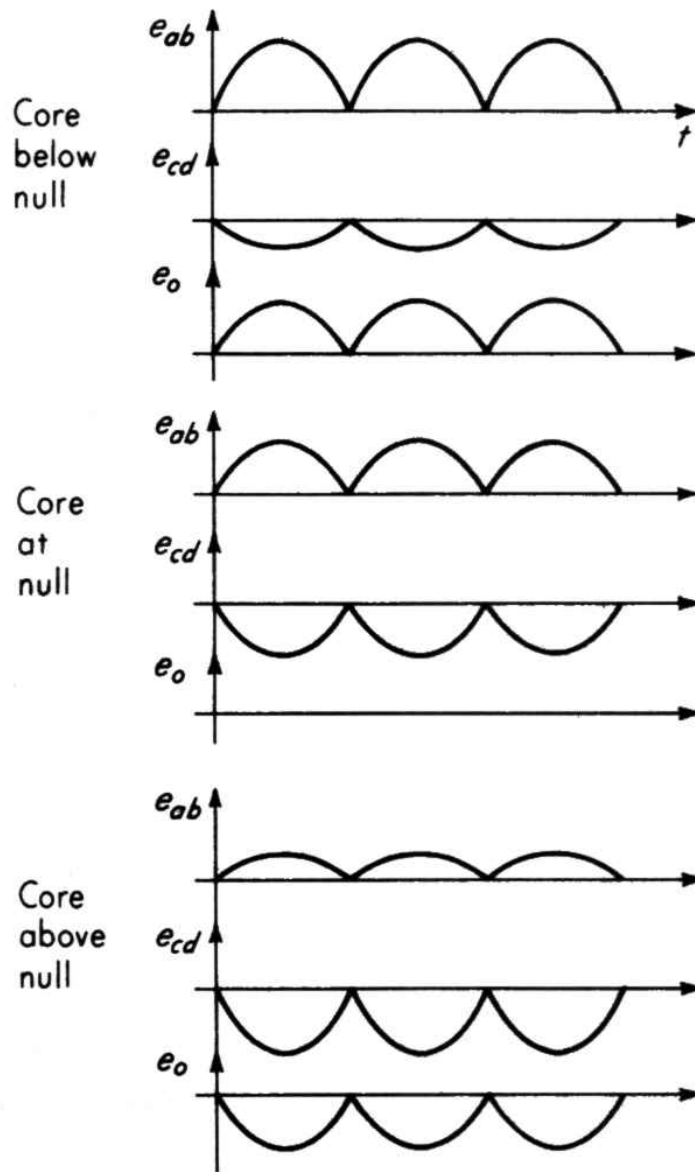




$$e_o = e_{ab} + e_{cd}$$

$$R \approx 1,000 \text{ to } 10,000 \Omega$$

Example of rectifier and phase demodulator ...



Dynamic example:

LVDT with a 10g nucleus, measuring a displacement of  $\pm 1\text{mm}$  at 1 kHz

Displacement:  $x(t) = X_0 \sin \omega t$

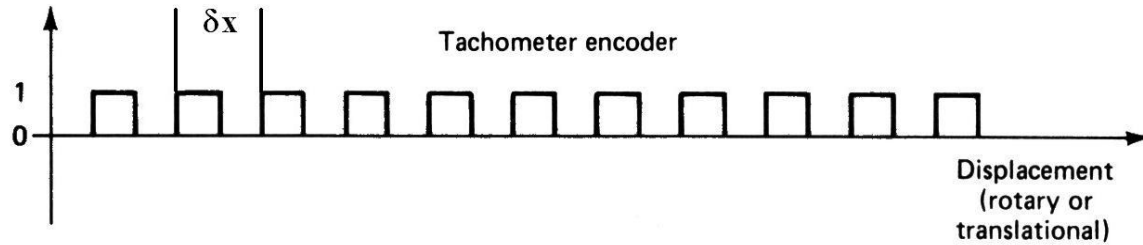
Acceleration (of the nucleus):  
 $\ddot{x}(t) = -\omega^2 X_0 \sin \omega t = \omega^2 X_0 \sin(\omega t - \pi)$

Whatever is the displacement we are measuring, to correctly pick up the  $\pm 1\text{mm}$  amplitude at 1kHz frequency, the external displacement must apply to the nucleus in every time instant a force  $F(t) = m\ddot{x}(t) = m \cdot \omega^2 X_0 \sin(\omega t - \pi)$  which is maximum at the inversion points:  $F_{\max} = m\ddot{X}_0 = m \cdot \omega^2 X_0$  which actually is ...

with  $\omega = 2\pi f = 6,28 \times 10^3 \text{ s}^{-1}$  and  $X_0 = 10^{-3} \text{ m}$   
 the **dynamic loading effect** ...

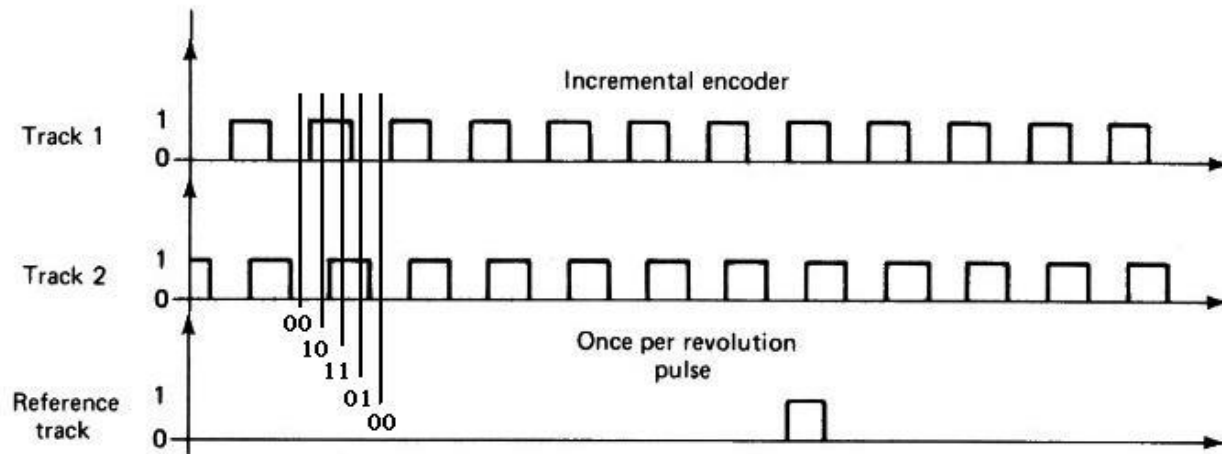
$$F_{\max} = 10^{-2} \text{ kg} \times 39,4 \cdot 10^6 \text{ s}^{-2} \times 10^{-3} \text{ m} = 394 \text{ kgms}^{-2} \cong 400 \text{ N}$$

# Digital ENCODERS

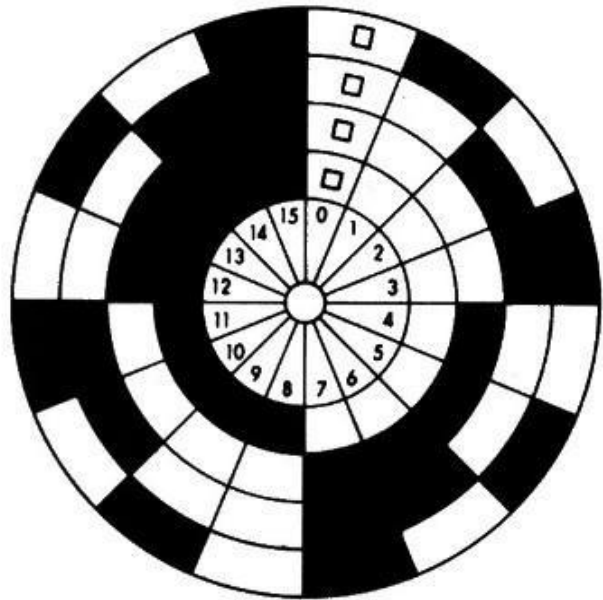


Encoders are “native digital” *motion transducers*. They are simply made by coupling a *notch trace* and a *notch reader* in relative motion by each other. The distance  $\delta x$  (*pitch*) between two consecutive notches is the fundamental design data of the encoder.

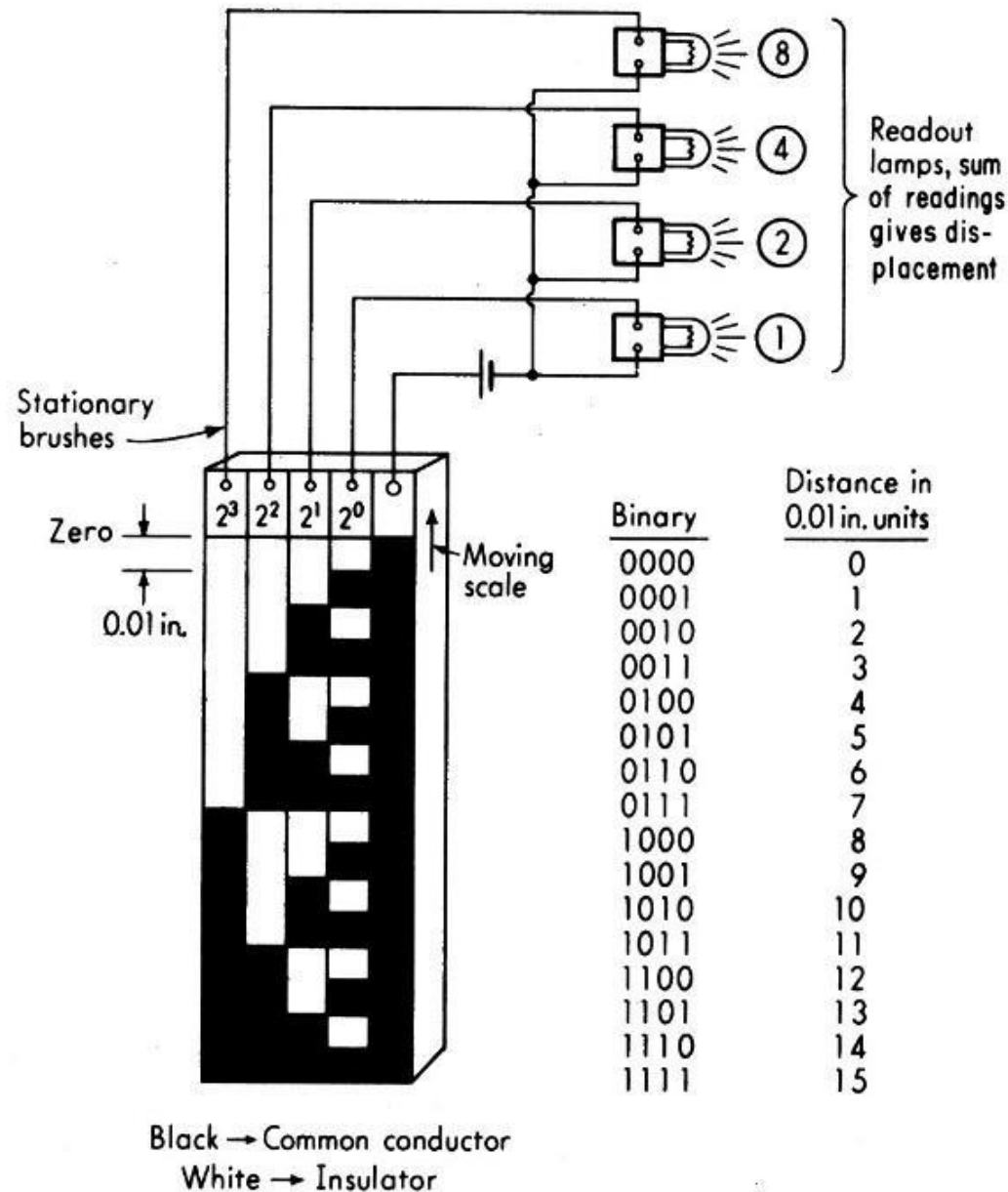
In **tachometric encoders** we just read the number of notches the sensor has counted and we have the distance:  $x = n \times \delta x$ . The *number of notches counted in each time unit* gives us also the velocity of the motion ! *Spatial resolution* is equal to  $\delta x/2$  but NO information about motion verse is provided by such transducer !



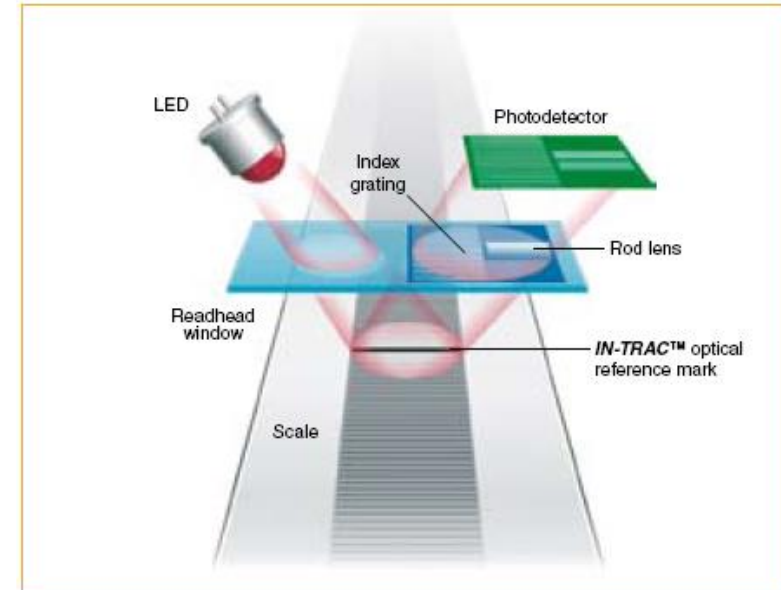
**Incremental encoders** can overcome this limit by using two notch traces, staggered each other with a pitch of  $\delta x/4$ . This is also the new *enhanced resolution* of the transducer. NO information about the absolute position is provided by such transducer !



Translational and rotary encoders.

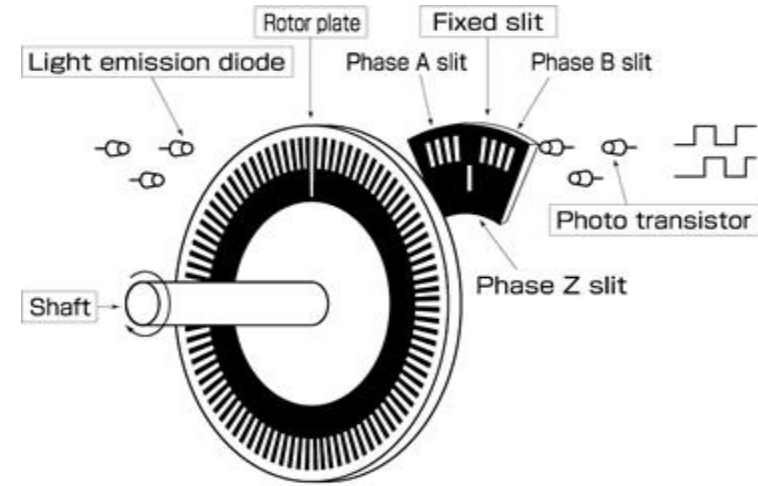
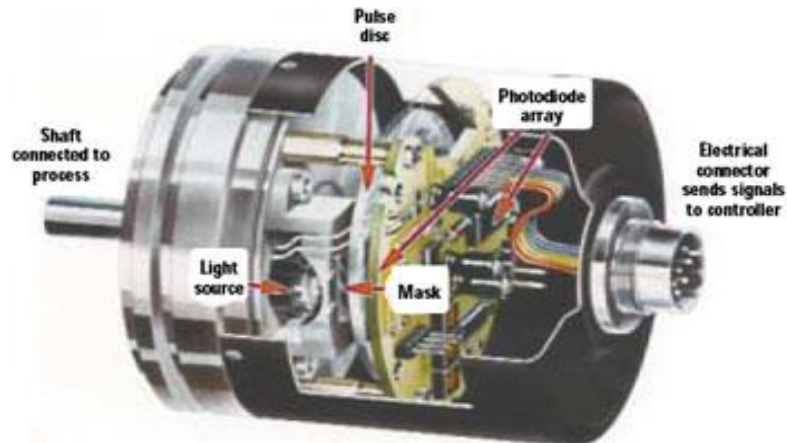
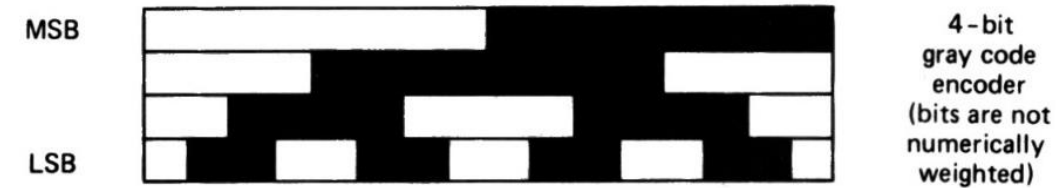
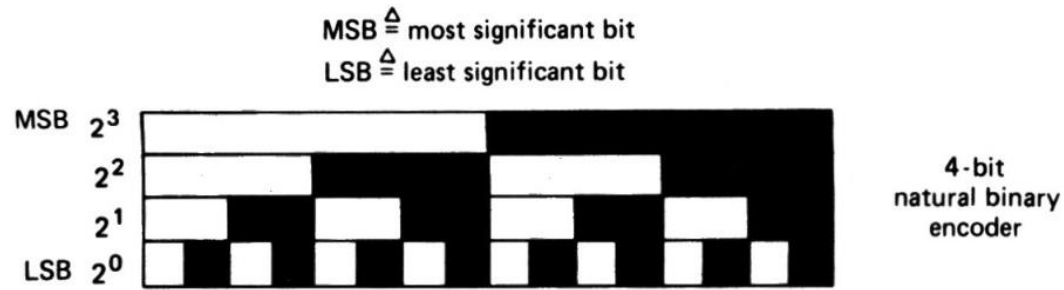


**Absolute encoders** make a direct association between the *actual position* and a *binary code* !  
They have as many notch traces (and readers) as the bit number that is needed !

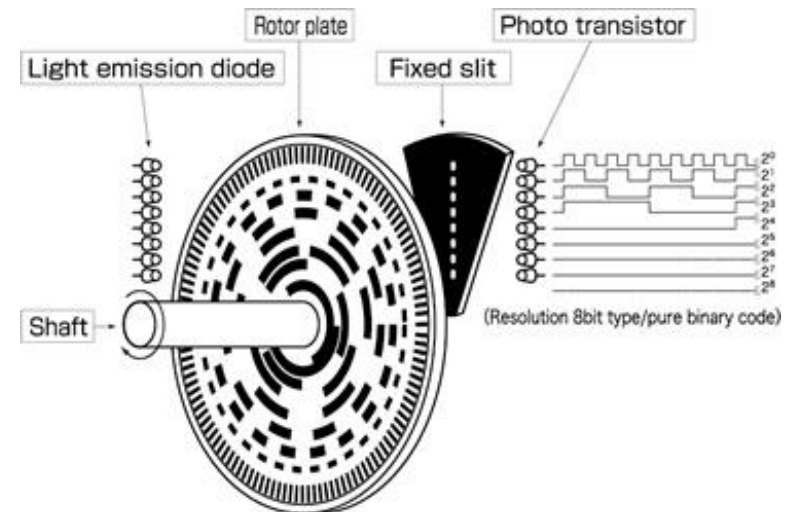


The **natural binary code** is not ideal for *encoders* because there are several transitions for which more than one bit is changing its state simultaneously ! This is not guaranteed in real devices and it can cause noise ...

Therefore, encoders employ the **grey binary code** where, for every step, there is always only one bit at a time that changes its state !



Incremental Encoder Simplified Structure



Absolute Encoder Simplified Structure